



0321.68095

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yeshaiah Fainman
Serial No.: 10/521,425
Conf. No.: 9057
Filed: 7/18/2003
For: HOLOGRAPHICALLY DEFINED
SURFACE MASK ETCHING
METHOD AND ETCHED OPTICAL
STRUCTURES
Art Unit: 2814
Examiner: Rao, Shrinivas H.

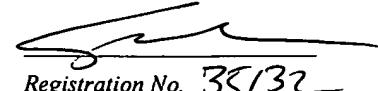
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7-22-08

Date

F-CLASS.WCM

Appr. February 20, 1998 Attorney for Applicant(s)



Registration No. 35132

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P.O. Box 1450
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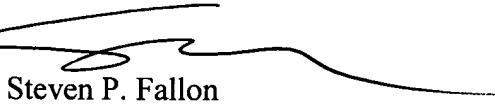
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Respectfully submitted,
GREER, BURNS & CRAIN, LTD.

By



Steven P. Fallon

Registration No. 35,132

July 22, 2008

300 South Wacker Drive, Suite 2500
Chicago, Illinois 60606
(312) 360-0080
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